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INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: 1039-CO2	Serial No.: Unassigned
	Applicant: Miller, et al.	Group: Unassigned
	Filing Date: Unassigned	Examiner: Unassigned

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if appropriate
AY	AA	5,963,788	10/05/1999	Barron, et al.	438	48	
AY	AB	6,174,820	01/16/2001	Habermehl, et al.	438	745	02/16/1999
AY	AC	6,178,284	01/23/2001	Bergmann, et al.	385	140	09/30/1998
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AG							
	AH							
	AI							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AY	AJ	Ayazi, Farrokh; Najafi, Khalil, "High Aspect-Ratio Combined Poly and Single-Crystal Silicon (HARPSS) MEMS Technology," Journal of Microelectromechanical Systems, Vol. 9, No. 3 September 2000, pp. 288-294.
AY	AK	Dichroic Filter Array™ Patent Patterned Coatings Technology, Ocean Optics, Inc., <a href="http://www.oceanoptics.com/products/dfa.asp">http://www.oceanoptics.com/products/dfa.asp</a> .
	AL	
	AM	
	AN	
	AO	

Examiner Qua Huang	Date Considered 06/02
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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.